

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Mitsuhiro ICHIJO, et al.) Confirmation No.: 7738
Application No. 10/804,053) Examiner: Long Pham
Filed: March 19, 2004) Group Art Unit: 2814
For: FILM FORMATION METHOD AND) Date: September 3, 2008
MANUFACTURING METHOD OF)
SEMICONDUCTOR DEVICE)

INFORMATION DISCLOSURE STATEMENT

Mailstop: Issue Fee

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicant hereby submits the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

Under 37 C.F.R. § 1.97(c), Applicant respectfully certifies that each item of information contained in the present information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the present information disclosure statement.

Applicant wishes to note that the reference cited on the attached PTO-1449 was previously cited in an Office Action of a counterpart Japanese patent application, No. 2003-076646 on June 17, 2008.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that the Examiner initial a copy of this form and return it to the undersigned.

The Commissioner is hereby authorized to charge the \$180 fee required for this submission and any other fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By: /Jeffrey L. Costellia, Reg. No. 35,483/
Jeffrey L. Costellia

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